

# **Al2O3/Si NPs multilayered antirefective coating to enhance the photovoltaic performance of solar cells**

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## **ABSTRACT**

In the present work, the enhancement in the efficiency of commercial solar cells through the use of  $\text{Al}_2\text{O}_3/\text{SiNPs}$  multilayer antireflecting coating, is reported. The  $\text{Al}_2\text{O}_3$  coatings were deposited by the atomic layer deposition technique, while the silicon nanoparticles were synthesized using a water-dispersible methodology. Based on photoluminescence and absorbance studies of the SiNPs, the underlying mechanism for this improvement can be atributed to the luminescent down-shifting efect. Thermoluminescence studies were achieved to confrm the formation of the  $Al_2O_3$  layer. The thickness of the  $Al_2O_3$  thin films were determined by spectroscopic ellipsometry in a range of 25 to 30 nm, while a SiNPs size of approximately 3 nm was obtained using dynamic light scatering method. The coatings of  $A_1O_3$  with SiNPs nanoparticles were deposited over solar cells to study their efficiency enhancement. Under a simulated one-sun illumination, coated solar cells achieved an enhancement of 6.74 mA/cm<sup>2</sup>, in short-circuit current density; while a 54.9% in power conversion efficiency increase was achieved, relative to those obtained for a pristine cell. The results show that the efficiency of solar cells can be signifcantly increased by combining the downshifting efect of the Si nanoparticles and the antireflective properties of the  $Al_2O_3$  films.

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# **1 Introduction**

An important research trend, at the fore front of world's attention is the improvement and better use of solar energy, through the use of solar cells (SC), carried out through the photovoltaic efect [\[1](#page-9-0)–[3](#page-9-1)]. Usually, SC are manufactured using silicon as active material due to their abundance, technological development, electrical characteristics, and adequate efficiency for power conversion [[4](#page-9-2)–[6](#page-10-0)]. In recent years, a great efort has been made by various research groups to improve the energy conversion efficiency of photovoltaic devices through diferent methods that include surface nano-texturization, anti-refective coatings, and surface passivation schemes, among others. However, refraction and reflection have been detected as main factors involved in decrease in the efficiency of solar cells [\[7](#page-10-1)–[10\]](#page-10-2). Consequently, several coating materials have been focused to solve these major challenges. Particularly, the power loss on silicon-based devices due to refections at the material interfaces, is still on discussion [[11\]](#page-10-3).

Since pure silicon cell refects 31–51% of the light reaching their surface, it would only transmit in about 70% of IR and 50% of UV of the sunlight to the cell [\[12\]](#page-10-4). Because of that, it is evident that an improvement in the efficiency of silicon solar cells is necessary  $[13-15]$  $[13-15]$  $[13-15]$  $[13-15]$ . On that sense, antireflecting coatings (ARC) have been incorporated in the solar cell fabrication process [[16](#page-10-7)–[18](#page-10-8)]. Commonly, ARCs are applied on the cover glass and/or directly on the SC and recently; these coatings have been combined with other materials to also consider the soiling problem, using self-clean-ing process [[19](#page-10-9)]. SiO<sub>2</sub>, MgF<sub>2</sub>, SnO<sub>2</sub>, SiC, TiO<sub>2</sub>, Al<sub>2</sub>O<sub>3</sub>, and  $ZrO<sub>2</sub>$  are the materials most commonly used as antireflection coating in photovoltaic solar cells [[20\]](#page-10-10). In applications where, in addition to antireflective coatings, self-cleaning is required,  $\text{Al}_2\text{O}_3$  is one of the most suitable materials; when this material is applied in double and triple layer coatings, satisfactory results are obtained in terms of adhesion to the surface and durability. In multilayer anti-refective coatings, the use of  $\text{Al}_2\text{O}_3$  reduces reflectance because it is a material with a low refractive index, which increases light transmitance [[19\]](#page-10-9). Diferent fabrication methods have been employed for ARC production such as magnetron sputering [[21\]](#page-10-11), e-beam evaporation [\[22](#page-10-12)], chemical vapor deposition (CVD) [[23\]](#page-10-13), pulsed laser deposition  $(PLD)$  [\[24](#page-10-14)], dip coating [[25\]](#page-10-15) and sol–gel, among others [\[26,](#page-10-16) [27\]](#page-10-17). It has been found that the ALD-grown  $Al_2O_3$  coating has an average transmitance of 99% in the range of 350 nm to 800 nm and this method of preparation ARC has the advantage of broadband antireflection performance, is a simple fabrication process, and can be obtained using a batch processing [\[28](#page-10-18)].

Another problem, currently related to solar cells fabrication, is that these devices do not get to take full advantage of the UV solar radiation. That is the underlaying reason that motivates an intense search for alternatives and, for beter use of this high energy radiation. Those materials which make use of this segment of the electromagnetic spectrum, do it through an effect known as down shifting effect. This phenomenon consists of the absorption of high-energy photons with their subsequent re-emission with a lower energy, towards the depletion region of the solar cell. In this way, these photons will contribute to the photocurrent increase [[29,](#page-10-19) [30\]](#page-10-20).

Diferent materials have been explored to enhance the power conversion efficiency through the down shifting phenomena of solar cells using nanoparticles (NPs), and its behavior can be approached to a conductor or semiconductor. Considering the frst one, a promising method was reported incorporating localized surface plasmon resonance produced by Au, Ag and Cu nanoparticles [\[31](#page-11-0)–[33\]](#page-11-1). The application of metallic  $NP<sub>S</sub>$  in photovoltaics has been widely studied because they can be simply deposited without modifying the device structure; thus, signifcantly increasing the efficiency of commercial solar cells  $[34]$  $[34]$ .

From another perspective, semiconductor NPs represents a promising and cost-efective alternative to improve the efficiency of photovoltaic devices. The down shifting phenomena produced by silicon nanoparticles (SiNPs), has been reported to increase the efficiency of the solar cells  $[35]$  $[35]$ . In this process, luminescent nanoparticles absorb a high energy photon, which, in turn, emit photons at longer wavelengths. A recent result of our research group using a down shifting conversion process, has shown an increase in a range of 11 to 17% in the solar cells efficiency, has been obtained [\[36](#page-11-4), [37](#page-11-5)].

In this work it is presented a combined structure consisting of a  $\text{Al}_2\text{O}_3$ / SiNPs multilayer antireflective coating. The SiNPs presented a 459 nm emission in the visible range, revealed by photoluminescent spectroscopy. The  $Al_2O_3$  thin films deposited by atomic layer deposition (ALD) containing silicon NPs, described a combined efect, acting as antirefective coating and showing the down shifting efect, which resulted in an increase in the solar cell efficiency. The  $\text{Al}_2\text{O}_3/\text{SiNPs}$ multilayer coating was deposited over commercial Silicon solar cells, improving their efficiency up to 54%.

## **2 Experimental procedure**

## **2.1 Fabrication**

#### *2.1.1 Nanoparticles synthesis*

For the present study, the silicon nanoparticles were prepared by adding 1 mL of APTES to 4 mL of deionized water (DI-water) and stirring it for 10 min. After that, 1.25 mL of 0.1 M sodium L-ascorbate $\geq$ 98%  $(C_6H_7NaO_6)$  (SA) was added to the previous mixture and stirred by 20 min, as is shown in Fig. [1](#page-2-0). The SiNPs were deposited over solar cells by means of the spincoating methodology, which consists of depositing a flm from a solution, on a SC substrate placed on a rotating system. The solution was spin coated over the surface, creating a uniform layer. In this way, 1 mL of the SiNPs solution was deposited on the SC, at a speed of 4000 RPM for 60 s. To study the method reproducibility, four samples labeled as A1-A4 were synthesized under the same parameters.

#### *2.1.2 Al2O3 deposited by ALD*

To synthesize the  $Al_2O_3$  thin films, trimethyl-aluminum (TMA) (98%, purity) was used as precursor,  $H<sub>2</sub>O$  as reactant material, an oxygen source, and  $N<sub>2</sub>$ , (99.999%, purity) as a purging gas, with a volumetric flow of 100 sccm, at 180  $^{\circ}$ C. The method consists of repetitive deposition cycles occurring inside the reaction chamber, alternating the precursor gas, the reactant gas intake, as well as, the nitrogen flow, used as purging gas. That procedure is summarized in Table [1.](#page-3-0)

## *2.1.3 Al2O3 with silicon nanoparticle, deposited over solar cells*

The SiNPs working conditions previously mentioned were used, as well as those described for the  $Al_2O_3$ thin flms fabrication. Figure [2](#page-3-1) shows a scheme of the



<span id="page-2-0"></span>

<span id="page-3-0"></span>**Table 1** Parameters of  $AI_2O_3$  nanolaminates deposited by  $ALD$ 

Parameter	Value
Cycles	100
Temperature	$\sim$ 180 °C
Time of TMA	$20 - 125$ ms
TMA time of purge.	15 <sub>s</sub>
Time of H <sub>2</sub> O	$100 \text{ ms}$
$H2O$ time of purge	15 <sub>s</sub>
Work pressure	1.8 Torr
Nitrogen flux	$\sim$ 101 sccm



<span id="page-3-1"></span>**Fig. 2**  $\text{Al}_2\text{O}_3$  thin films with silicon nanoparticles deposited over solar cell



<span id="page-3-2"></span>**Fig. 3** Schematic diagram showing the mechanism of photon trajectories in the coating of  $Al_2O_3$  and SiNPs

structure produced after achieving a three-layer coating of  $\text{Al}_2\text{O}_3$  with silicon nanoparticles. The electrical measurements were carried out after depositing each layer represented in Fig. [2](#page-3-1) as M1, M2 and M3.

Figure [3](#page-3-2) shows the interaction between the incident radiation and the  $\text{Al}_2\text{O}_3$ -SiNPs ARC. The UV region of the incident solar spectrum will be absorbed by the embedded silicon nanoparticles and reemited as visible light. Due to the refractive index of the ARC, an important part of the isotropic emission of the SiNPs

<span id="page-3-3"></span>



will be reflected from the ARC-air interface and transmited to the solar cell surface. The wavelength region within visible range, where silicon solar cells had good spectral response, will be efficiently transmitted to the device due to the antireflective effect of the  $Al_2O_3$  thin film. The synergistic effect of the down-shifting properties of the SiNPs and the antirefective efect of the  $Al_2O_3$  thin film maximizes the electron–hole pair generation within the PN junction which is refected as enhanced power conversion efficiency on the solar cell.

## **3 Results and discussions**

### **3.1 SiNPs characterization**

The size distribution of SiQDs was measured with a Malvern Zetasizer Nano Series using dynamic light scattering method (DLS). The A1-A3 samples have an average size of 3.50 nm with a standard deviation of 0.91 nm. By contrast, the A4 sample shows an average size of 2.99 nm with a standard deviation of 0.33 nm, as can be seen in Table [2.](#page-3-3) Those results demonstrate that silicon nanoparticles have a very controlled size and distribution. Because all the samples presented a similar size distribution as exhibited in Fig. [4a](#page-4-0), the sample A3 was selected for optical analyzes. This sample presented an absorption spectrum tapering off beyond  $\sim$  500 nm as is shown in Fig. [4](#page-4-0)b. Employing the Tauc´s Law, from the absorption spectrum, it is possible to determine the bandgap energy value of the SiNPs. Accordingly, to a direct bandgap material:

$$
hv = A(\alpha hv)^{1/n} + E_g \tag{1}
$$

where  $\alpha$  is the absorption coefficient,  $h$  is the Planck's constant,  $v$  is the photon frequency,  $E<sub>g</sub>$  is the bandgap, *A* is a constant and  $n = 1/2$  given the nature of the electronic transitions (direct allowed). Figure [4c](#page-4-0) shows the  $(ahv)^2$  vs *hv* graph, as well as the linear fitting, and the obtained  $E_{\rm g}$  value. The average  $E_{\rm g}$  determined from



<span id="page-4-0"></span>**Fig. 4** Histogram showing the size distribution of silicon nanoparticles, **b** absorption and Photoluminescence spectra of SiNPs, **c** bandgap determination of SiNPs

the samples, was  $2.96 \pm 0.03$  eV. The absorbance and  $E_{\sigma}$  results demonstrate the efficiency of the synthesis method. Figure [4](#page-4-0)b shows the photoluminescence response of the A3 SiNPs sample. The synthesized silicon nanoparticles were measured with a 325 nm Kimmon IK Series He-Cd laser, an Ocean Optics model Red Tide USB650 detector, provided with an Ocean Optics View Spectroscopy Software version 1.6.7. The PL spectra consists of broadband signal extending from 375 to 650 nm in all cases with a peak position at 459 nm.

The nanoparticles obtained in this stage were subsequently deposited on commercial solar cells without coating. It was also used to develop the coatings by combining them with  $Al_2O_3$  thin films that were also deposited on commercial solar cells, achieving a substantial increase in their efficiency.

## **3.2 Characterization of Al<sub>2</sub>O<sub>3</sub>**

#### *3.2.1 Thermoluminescence of Al<sub>2</sub>O<sub>3</sub>*

Thermoluminescence (TL) experiments were carried out using the RIS∅ TL/OSL reader model TL DA-20 equipped with a  $\frac{90}{5}$ r/ $\frac{90}{1}$  beta particle source with an activity of 40 mCi and a dose rate of 5 Gy/min, with a linear heating rate of 5 °C/s from room temperature up to 300 °C in a  $N_2$  atmosphere.

Figure [5](#page-5-0) shows the behavior of the thermoluminescence of the  $Al_2O_3$  thin film deposited with 300 ALD cycles, it was exposed to beta radiation in a dose range of 83 to 7200 Gy. The TL glow curves are displayed at different doses, indicating that as the radiation dose increases, the thermoluminescence signal is also increased. A broad TL band is observed in the range



<span id="page-5-0"></span>**Fig. 5** Glow curve of thermoluminescence spectrum of  $AI_2O_3$ 

from 50 to 350 °C, apparently composed of several thermoluminescence peaks, with a maximum around 150 °C. In the inset of Fig. [4,](#page-4-0) can be appreciate the area under the curve of the TL with respect to radiation doses, a well-defned linear behavior without apparent saturation is observed. The TL results are very close to those reported in the literature for  $Al_2O_3$  [[38](#page-11-6)–[40\]](#page-11-7).

#### *3.2.2 X‑ray photoelectron spectroscopy of Al2O3*

The X-ray photoelectron spectroscopy (XPS) survey spectra (0–1250 eV) of  $Al_2O_3$  thin films are shown in Fig. [6](#page-6-0). XPS was performed with a Perkin Elmer PHI5100 to study the chemical composition on the different samples; the studies were done with a Mg source at 15 keV and 300 W with a pressure of 4 × 10–8 Torr. The observed signals are associated to Al and O, meaning that the flms are free of contaminants. It can be noticed the existence of C1s peaks, which is usually found as residual trace and it is considered as the calibration reference [[41](#page-11-8)–[43\]](#page-11-9).

Figure [7](#page-6-1) shows (a) the peak corresponding to aluminum 2p (74.9 eV) and (b) O 1s (531.22 eV), which match well when compared to the corresponding data reported in the literature considering the  $Al_2O_3$ compound.

#### *3.2.3 Spectroscopic ellipsometry determinations.*

As detailed in the experimental part, three layers of 20 nm  $\text{Al}_2\text{O}_3$  were stacked with three layers of SiNP's. Figure [8a](#page-7-0), b shows the raw ellipsometry Psi  $(\Psi)$  and delta  $(\Delta)$  of the stacked three layers, i.e., 20, 40, and 60 nm. The ellipsometry data was taken at an angle of 65°. Two points from the raw measurements can be highlighted. As the thickness increases, the interference shifts to longer wavelengths, and the delta  $(∆)$  is more sensitive to thickness change than psi  $(\Psi)$ . Both assertions agree with the basic theory of ellipsometry [[44](#page-11-10)].

On the other hand, Fig. [8](#page-7-0)a and b also shows the ftting used with the Cauchy model to process the data. Cauchy's theory is usually used in ellipsometry measurements of transparent oxides with high bandgaps, such as  $Al_2O_3$  [\[45](#page-11-11)]. Its basic formula for the refractive index calculation is as follows:

$$
n(\lambda) = A + \frac{B}{\lambda^2} + \frac{C}{\lambda^4}
$$
 (2)

where *A*, *B*, and *C* are the Cauchy parameters. Figure [8c](#page-7-0) shows the refractive index profle of the three  $Al_2O_3$  thicknesses calculated with the Cauchy model. In addition, the refractive index of bulk  $Al_2O_3$  taken from the T. Winchester handbook was added, for comparison purposes [[46\]](#page-11-12).

In Fig. [8](#page-7-0)d, we compare the refractive index of the  $Al_2O_3$  films vs thickness, where we add more points for better visualization. As the thickness of  $Al_2O_3$ increases, the refractive index increases. Firstly, the abrupt change in the refractive index, around 10 nm, is due to the growth mode of islands and layers, which predominate in the ALD process during the initial growth cycles  $[47, 48]$  $[47, 48]$  $[47, 48]$  $[47, 48]$ . The film is not entirely homogeneous during the frst layers, so the refractive index is low.

The other point to highlight is the diference in the refractive index in comparison to bulk  $Al_2O_3$  [\[46](#page-11-12)]. This, is mainly due to the density of the  $Al_2O_3$ . Bulk  $Al_2O_3$ crystals are usually fabricated at high temperatures, producing high-density materials.

## **3.3 SEM characterization** of  $AI<sub>2</sub>O<sub>3</sub>$  **thin** films **with SiNPs**

Figure [9](#page-7-1) shows the SEM images of the  $Al_2O_3$  and SiNPs over solar cells. The morphology was studied <span id="page-6-0"></span>**Fig. 6** XPS survey spectra of

KLL(O)

**O1s**

531.22eV

 $\ddot{\text{C}}$ 



18000

**Survey**

<span id="page-6-1"></span>**Fig. 7** Spectra showing the main XPS peaks of **a** Al 2p and **b** O 1s

with a JSM-7600F JEOL FESEM microscope, at the working conditions of 20 keV and 10<sup>-6</sup> Torr. Figure [9a](#page-7-1) shows the cross-section image of the solar cell with the  $\text{Al}_2\text{O}_3$  coating with SiNPs, in this image the coating is on the left side. Figure [9b](#page-7-1) shows the image of surface cell that contains the aluminum contact and the coating of  $Al_2O_3$  with SiNPs, as illustrated in the red rectangle. It is also observed that the coating is conformal because it follows the shape of the surface on which it was deposited. Figure [9](#page-7-1)c shows the high magnifcation SEM image of the  $\text{Al}_2\text{O}_3$  with SiNPs coating, consisting of 3 layers of 22 nm as proposed in Fig. [1](#page-2-0) as M1, M2 and M3.

## **3.4 Electrical characterization** of **nanolaminates** of  $AI_2O_3$  **and** silicon **nanoparticles**

In order to compare the performance of the  $Al_2O_3/$ SiNPs multilayer antirefection coating, SiNPs were deposited on solar cells and the *I*–*V* curves were measured as reference. In a frst stage, three silicon solar cells were coated with silicon nanoparticles according to the procedure described above, using commercial polycrystalline silicon solar cells (1.9 × 3.9 cm) as substrate. Current–voltage parameters were measured before and after the deposit of the SiNPs using a Keithley model 2400 source meter and the efficiency of the solar cells was determined using an Oriel LCS-100



<span id="page-7-0"></span>**Fig. 8 a** and **b** Shows the raw ellipsometry Psi (Ψ) and delta  $(\Delta)$  measured from the three Al<sub>2</sub>O<sub>3</sub> layers stacked with SNPs layers. **c** Shows the refractive index vs wavelength of the  $Al_2O_3$ , and **d** shows the refractive index vs thickness of  $Al_2O_3$ 



<span id="page-7-1"></span>**Fig. 9 a** SEM cross-section image of the solar cell with the  $A1_2O_3$  coating with SiNPs, **b** image of surface cell that contains the aluminum contact and the coating of  $\text{Al}_2\text{O}_3$  with SiNPs, **c** SEM image of the  $\text{Al}_2\text{O}_3$  with SiNPs coating



<span id="page-8-0"></span>**Fig. 10** *I*–*V* and *P–V* curves of SiNPs over Silicon solar cells

solar simulator. Figure [10](#page-8-0) shows the results of the electrical characterization and Table [5](#page-8-1) shows the open circuit voltage  $(V_{oc})$  and the short circuit current  $(I_{sc})$ , which are used to calculate the fill factor of solar cells (FF), being the most important parameter to determine the efficiency of SC.

The results obtained show that the solar cells coated with silicon nanoparticles, increased their efficiency from 6.38 to 8.20% (SC1 + SiNPs), from 7.14% to 7.53% (SC2 + SiNPs), and from 7.26 to 8.68% (SC3 + SiNPs). An increase average of 1.21% and 17.6% was obtained for efficiency and relative efficiency, respectively. The increase in the relative efficiency of solar cells is consistent with the results obtained in previous studies [\[36\]](#page-11-4).

In a second stage, In Fig. [11](#page-8-2), it can be seen that the efficiency of the solar cell increases as the coating cycles composed of  $\text{Al}_2\text{O}_3$  thin films and silicon nanoparticles, are increased. The pristine solar cell has an efficiency of 4.25% (SC). After performing one coating, it shows an efficiency of  $5.42\%$  (SCM1), which increases up to 5.63%, for two coating cycles (SCM2).

<span id="page-8-1"></span>**Table** 5 characte covered



<span id="page-8-2"></span>**Fig. 11** *I*–*V* and *P–V* curves of Silicon solar cell (SC\_E) covered with  $Al_2O_3$  thin films and SiNPs

Finally, after three deposition cycles, it shows an efficiency value of 6.59% (SCM3). The solar cell having three coatings including the encapsulated nanoparticles labeled as SCM3, has a relative efficiency of  $54\%$ , as can be shown in Table [6.](#page-9-3)

In summary, commercial solar cells with an efficiency between 6 and 7% were used, then SiNPs were deposited on these SCs, obtaining efficiencies around 8% on average, as shown in Fig. [9](#page-7-1), which yields an increase of 12% in the efficiency of the commercial solar cell. After this, the coatings composed of the antirefective flm and SiNPs were deposited. The commercial solar cells with one coating had an efficiency increase of 27%, with two coatings 32% and with three coatings 55%. These results demonstrate that the combined effects of  $\text{Al}_2\text{O}_3$  ARC and SiNPs improve the efficiency of commercial solar cells outstandingly.



$P_{\text{Max}}[W]$	$n\lceil\% \rceil$	FF[%]	$\eta_{\rm rel}$ [%]	
0.0315	4.25	34.69		
0.0402	5.42	46.94	27.47	
0.0418	5.64	49.76	32.55	
0.0488	6.59	58.82	54.99	

<span id="page-9-3"></span>**Table 6** Electrical characteristics of Solar cells covered with thin films of  $A_2O_2$  and silicon nanoparticles

# **4 Conclusions**

In the present work, the study of the infuence of coatings, based on  $\text{Al}_2\text{O}_3$  thin films and SiNPs and their effect on increase of the efficiency values of commercial solar cells is presented. The SiNPs were synthetized using a water-dispersible method, while the  $Al_2O_3$  coatings were fabricated by the ALD technique. The SiNPs presented the down shifting efect as was demonstrated by their photoluminescence results. Experimental results showed that the incorporation of silicon quantum dots (Si-QDs) as down-shifting material on the window side of a solar cell, improves the photocurrent generation. That was observed in our samples with a current density increase from 33.42 to 38.28 mA/cm<sup>2</sup> and an open circuit voltage value from 532.57 to 536.20 mV. The coating SiNPs with  $Al_2O_3$  presented a combined effect, behaving as antireflective coating and down shifting material, increasing the solar cell efficiency. The coating of NPs in  $\text{Al}_2\text{O}_3$  thin films improved their efficiency up to 54.99%. The increase on the efficiency obtained is outstanding with respect to those reported in other works that use only nanoparticles or only antirefective coatings. Therefore, the structure of multilayered antirefective flms containing nanoparticles, proposed in this work, opens the possibility of carrying out a more exhaustive investigation on this subject.

# **Author contributions**

All authors contributed to the study conception and design. Material preparation, data collection and analysis were performed by DBM, RRS, ARC, RGG and RMA. JLVA and PBP optically characterized the coating. The frst draft of the manuscript was writen by DBM, RRS, AR and all authors commented on previous versions of the manuscript. All authors read and approved the final manuscript.

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The authors declare they have no fnancial interests.

# **Data availability**

All authors declare that all data and materials used in this article comply with the standards in the area of semiconductor devices.

# **Code availability**

Not applied.

# **Declarations**

**Conflict of interest** The authors have no relevant fnancial or non-fnancial interests to disclose.

**Ethical approval** All authors accepted that the principles of ethical and professional conduct have been followed.

**Consent to participate** All authors consent to participate in the article.

**Consent for publication** All authors give their consent for the publication of the article.

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